on the belo	oostage, in an e ow date:	orrespondence is being depos	AILING UNDER 37 C.F.R. §1 Sited with the United States Postatissioner for Patents, P. O. Boy 15	.8 al Service as first class mail, with 180, Alexandria VA 22312 1450,	BRINKS HOFEF GILSON		
Date: _Au	gust 18, 2004			TRADEMARK OFFICE	&LIONE		
ln re A		Heinrich Ollendorf					
Appln.	No.:	10/777,608		Examiner:			
Filed:	•	February 11, 2004		Art Unit: 2812			
For:		POST METAL CHE POLISHING DRY (EMICAL MECHANICA	AL .			
Attorn	Attorney Docket No: 2003 P 54807 US (BHGL No. 10808/119)						
P. O. B	ssioner for F ox 1450 dria, VA 22			TRANSMITTAL			
Attach	ed is/are:						
	Transmittal Letter (in duplicate); Information Disclosure Statement (in duplicate); Form PTO-1449; Copy of Cited References						
□ Return Receipt Postcard □ Return Receipt Postcard							
Fee ca	lculation:						
\boxtimes	No additional fee is required.						
	Small Entity.						
	An extension fee in an amount of \$ for amonth extension of time under 37 C.F.R. § 1.136(a).						
	A petition or processing fee in an amount of \$ under 37 C.F.R. § 1.17().						
	An addition	I filing fee has been cal	culated as shown below:				
			Γ				

					Sma	Small Entity		Not a Small Entity	
	Claims Remaining After Amendment		Highest No. Previously Paid For	Present Extra	Rate	Add'l Fee	or	Rate	Add'l Fee
Total		Minus			x \$9=			x \$18=	
Indep.		Minus			x 43=			x \$86=	
First Presentation of Multiple Dep. Claim			+\$145=			+ \$290=			
					Total	\$		Total	\$

_		Total	\$	Total	\$	
Fee	payment:					
	A check in the amount of \$ is enclosed.					
	Please charge Deposit Account No. 23-1925 in the amount of for this purpose.	f \$. A copy of	this Transmitt	al is enclo	sed
	Payment by credit card in the amount of \$ (Form PTO-	2038 is a	attached).			
	The Director is hereby authorized to charge payment of any and any patent application processing fees under 37 CFR extension fee required to ensure that this paper is timely Account No. 23-1925.	§ 1.17 a	associated v	with this papeı	r (includin	ig an

Date 18,2004

Respectfully submitted,

Josen W. Fleriage (Reg. No. 52,897)



I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope, with sufficient postage, addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

August 18, 2004

Date of Deposit

Joseph W. Flerlage, Reg. 52,897

Name of Applicant, Assignee or Registered Representative

Signature

Date of Signature

Our Case No.: 2003 P 54807 US

(BHGL No. 10808/119)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner:

Group Art Unit No.: 2812

In re Application of:

Heinrich Ollendorf et al.

Serial No.: 10/777,608

Filing Date: February 11, 2004

For: POST METAL CHEMICAL

MECHANICAL POLISHING DRY

CLEANING

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Alexandria, VA 22313-1450

Dear Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Information Disclosure Statement be entered and the documents listed below and on the attached Form PTO-1449 be considered by the Examiner and

Applicant(s) respectfully request that the listed documents be made of record in the present case.

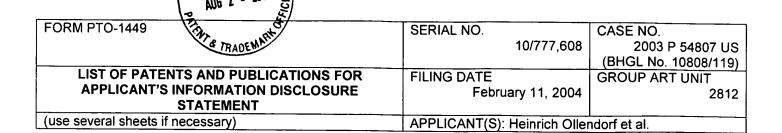


Respectfully submitted,

Joseph W. Flerlage

Registration No. 52,897 Attorney for Applicant(s)

BRINKS HOFER GILSON & LIONE P.O. Box 10395 Chicago, IL 60610 (312) 321-4200



EXAMINER INITIAL	(li syn	OTHER ART – NON PATENT LITERATURE DOCUMENTS nclude name of author, title of the article (when appropriate), title of the item (book, magazine, journal, serial, nposium, catalog, etc.), date page(s), volume-issue number(s), publisher, city and/or country where published.
	A1	Kelly H. Block, Heather L. Rayle, "Integration of CMP with Low-k Materials", Semiconductor International, Entegris, Reed Business Information, a division of Reed Elsevier Inc., (June 1, 2002), 7 pages.
	A2	Maria A. Lester, Associate Editor, "Post-CMP Cleaning Enhanced on Ploy-Si Film", Semiconductor International, Focus Dry, Reed Business Information, a division of Reed Elsevier Inc., (July 1, 2002), 2 pages.
	A3	Souvik Banerjee, Andrea Via, Harlan F. Chung, Robert J. Small, "Combining Aqueous and Cryogenic Post-CMP Cleaning", Semiconductor International, Solid State Equipment Corporation, Reed Business Information, a division of Reed Elsevier Inc., (February 1, 2003), 7 pages.
	A4	Michael R. Oliver, "Chemical Mechanical Polishing", Semiconductor International, ASML, Reed Business Information, a division of Reed Elsevier Inc., (June 1, 2003), 2 pages.

EXAMINER	DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

made of resord. Copies of the listed documents required by 37 C.F.R. § 1.98(a)(2) are enclosed for the convenience of the Examiner.

The references now cited are the following:

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

Kelly H. Block, Heather L. Rayle, "Integration of CMP with Low-k Materials", Semiconductor International, Entegris, Reed Business Information, a division of Reed Elsevier Inc., (June 1, 2002), 7 pages.

Maria A. Lester, Associate Editor, "Post-CMP Cleaning Enhanced on Ploy-Si Film", Semiconductor International, Focus Dry, Reed Business Information, a division of Reed Elsevier Inc., (July 1, 2002), 2 pages.

Souvik Banerjee, Andrea Via, Harlan F. Chung, Robert J. Small, "Combining Aqueous and Cryogenic Post-CMP Cleaning", Semiconductor International, Solid State Equipment Corporation, Reed Business Information, a division of Reed Elsevier Inc., (February 1, 2003), 7 pages.

Michael R. Oliver, "Chemical Mechanical Polishing", Semiconductor International, ASML, Reed Business Information, a division of Reed Elsevier Inc., (June 1, 2003), 2 pages.

In accordance with 37 C.F.R. § 1.97(g),(h), this Information Disclosure Statement is not to be construed as a representation that a search has been made and is not to be construed to be an admission that the information cited is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b).

This Information Disclosure Statement is being filed prior to the receipt of the first Official Action reflecting an examination on the merits and hence is believed to be timely filed in accordance with 37 C.F.R. § 1.97(b). No fees are believed to be due in connection with filing of this Information Disclosure Statement, however, should any fees under 37 C.F.R. §§ 1.16 to 1.21 be deemed necessary for any reason relating to these material, the Commissioner is hereby authorized to deduct said fees from Brinks Hofer Gilson & Lione Deposit Account No. 23-1925. A duplicate copy of this document is enclosed.